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GROUP 1700**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****PATENT**

Applicant: MAJIMA et al.

Examiner: VO, Hai

Serial No.: 09/890,550

Group No.: 1771

Filed: January 14, 2002

Title: POROUS SILICON CARBIDE SINTER AND SILICON CARBIDE-METAL
COMPOSITE THAT ARE OPTIMAL FOR A WAFER GRINDER TABLE**AMENDMENT****CERTIFICATE OF FACSIMILE TRANSMISSION**

I hereby certify that this correspondence is being transmitted
to the Commissioner for Patents, Alexandria, VA
22313-1450, via facsimile (fax no. 703-872-9310)
on 5-27-03.

 Reg No. 40,764
Mark D. Passler

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

This is in response to the Office Action dated November 27, 2002. This amendment is presented using the revised format permitted as of January 31, 2003. Please amend the above-identified application as follows:

Amendments to the claims begin on page 2 of this paper.

Remarks/arguments begin on page 4 of this paper.